

Docket No.:0756-7244

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE PATENT application of)
Koichiro TANAKA, et al.)
Serial No. 10/749,505) Group Art Unit: 2828
Filed: January 2, 2004) Examiner: Minsun Harvey
For: LASER IRRADIATION METHOD, METHOD)
FOR MANUFACTURING SEMICONDUCTOR)
DEVICE, AND LASER IRRADIATION SYSTEM)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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Randy L. Kiser

REQUEST FOR STATUS

Honorable Commissioner of Patents


P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,


Eric J. Robinson
Reg. No. 38,285

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